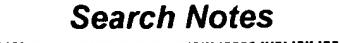


Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/649,738	CHOI ET AL.
Examiner	Art Unit	
Mike Qi	2871	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner